

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: David C. Fairbourn  
Serial No: 10/613,620  
Filing Date: July 3, 2003  
Art Unit: 1762  
Confirmation No.: 4378  
Examiner: Bret P. Chen  
Title: SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM  
AND METHODS FOR DEPOSITING MULTIPLE-METAL  
ALUMINIDE COATINGS  
Attorney Docket: MTCL-09

Cincinnati, Ohio 45202

July 5, 2007

Mail Stop Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AFTER-FINAL RESPONSE**

Sir:

In response to the Office Action mailed on May 11, 2007, please enter the following remarks.